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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Yukiko NISHIOKA et al.

Serial No. 10/536,961

Filed May 31, 2005

SUBSTRATE CLEANING APPARATUS
AND METHOD

: **Confirmation No. 6378**

: **Mail Stop: OFFICE OF INITIAL
PATENT EXAMINATION'S FILING
RECEIPT CORRECTIONS**

: Attorney Docket No. 2005-0880A

REQUEST FOR CORRECTED FILING RECEIPT

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Sir:

A corrected filing receipt is requested in the above-referenced case. A copy of the original filing receipt is enclosed, with the changes noted thereon.

Expedited issuance of the corrected filing receipt is respectfully requested.

Respectfully submitted,

Yukiko NISHIOKA et al.

By

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CONFIRMATION NO. 6378

FILING RECEIPT



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513
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Power of Attorney: The patent practitioners associated with Customer Number 513.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/07560 05/26/2004

Foreign Applications

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Projected Publication Date: 11/03/2005

Non-Publication Request: No

Early Publication Request: No

Title

Substrate cleaning apparatus and method

Preliminary Class

134

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